



P/1250-260

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of  
Tatsufumi KUSUDA et al.  
Serial No.: 10/661,240  
Filed: September 11, 2003

New York, New York  
Date: December 12, 2003  
Group Art Unit: ---  
Examiner: ---

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Max Moskowitz

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Signature

December 12, 2003  
Date of Signature

Respectfully submitted,

Max Moskowitz

Registration No.: 30,576

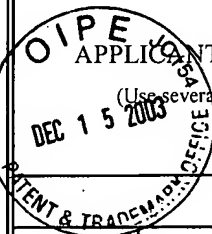
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MM:mjb  
Enclosures

 <p><b>APPLICANT'S ART CITATION</b> (Use several sheets if necessary)</p>		Application 10/661,240		OFGS File No. P/1250-260			
		Applicant Tatsufumi KUSUDA et al.					
		Filing Date September 11, 2003		Group Art Unit ---			
<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
	US-5,837,058	11-1998	Chen et al. (corresponds to JP 10-074705)	118	728		
	US-4,571,486	02-1986	Arai et al. (corresponds to JP 59-169125)	219	254		
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	US-6,026,589	02-2000	Yao et al. (corresponds to JP2002-502117)	34	78		
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<b>FOREIGN PATENT DOCUMENTS</b>							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	2000-355766	12-2000	Japan			x	
	63-166219	07-1988	Japan			x	
	2001-237195	08-2001	Japan			x	
	57-162340	10-1982	Japan			x	
	10-074705	03-1998	Japan			x	
	59-169125	09-1984	Japan			x	
	60-258928	12-1985	Japan			x	
	2002-502117	01-2002	Japan			x	
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
Examiner		Date Considered					
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